

PATENT Customer No. 22,852 Attorney Docket No. 4329.3100-00

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:	
Kei HAYASAKI et al.	Group Art Unit: 1756
Application No.: 10/624,593	) Examiner: Barreca, Nicole M.
Filed: July 23, 2003	Confirmation No. 7500
For: METHOD FOR FORMING A PATTERN AND SUBSTRATE- PROCESSING APPARATUS	) ) )
Maril Oirea Asserbates and	

Mail Stop Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

## REPLY TO OFFICE ACTION

In reply to the Office Action mailed September 28, 2005, the period for response having been extended through February 28, 2006, by a concurrently filed petition for extension of time and fee, please amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing of claims in this paper.

Remarks/Arguments follow the amendment sections of this paper.

03/01/2006 JADDO1

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